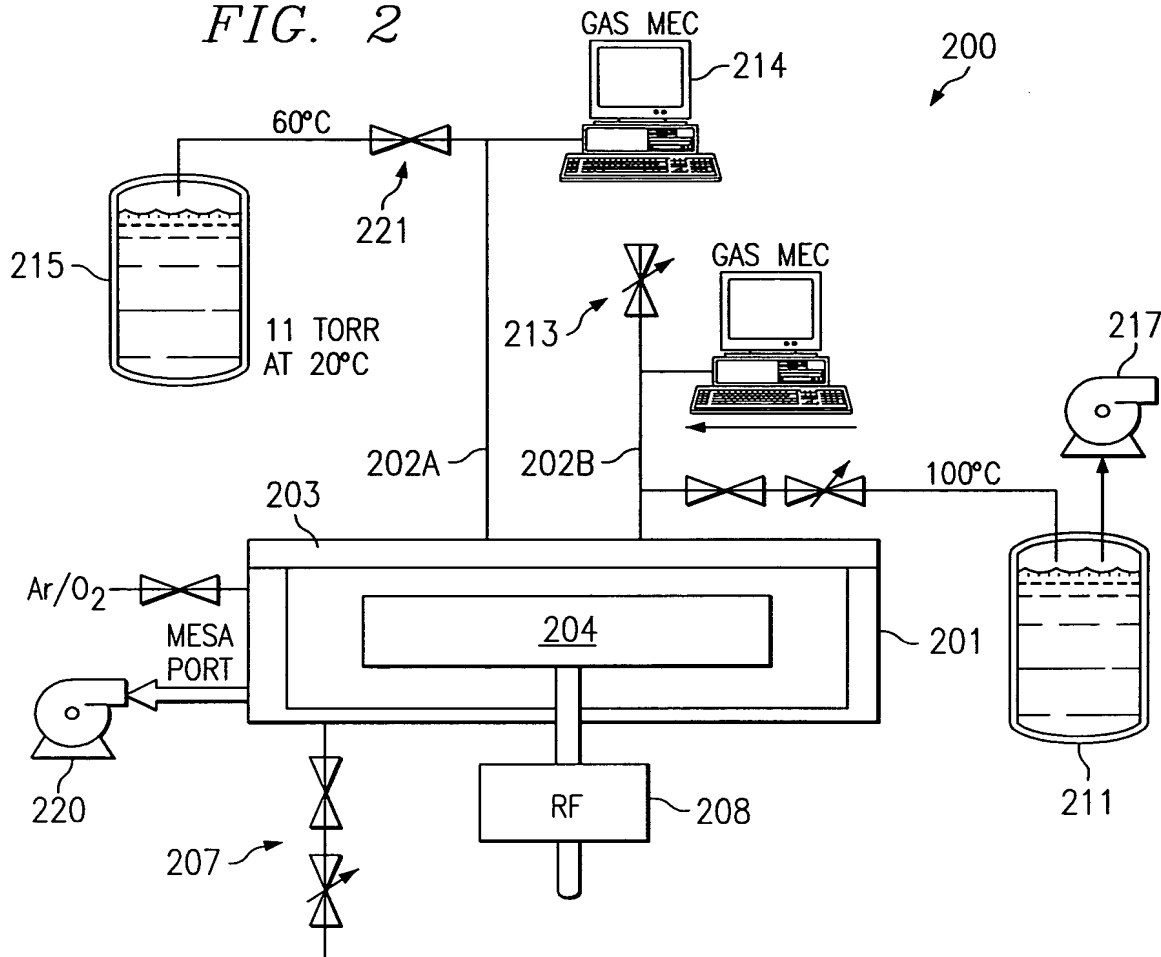


FIG. 2



300

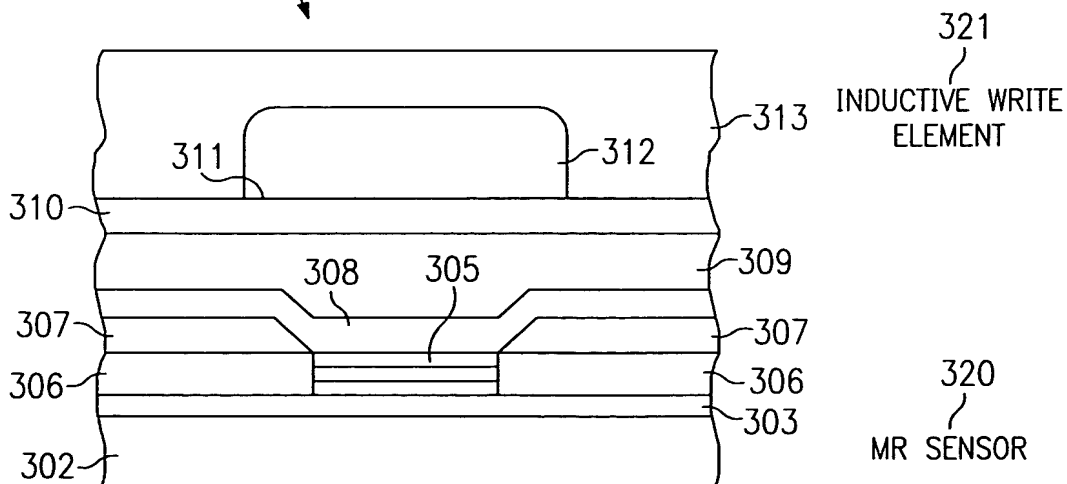


FIG. 3

REVISED	O.G. FIG.
BY	CLASS
CRAFTSMAN	SUBC

ATOMIC LAYER DEPOSITION FOR FABRICATING THIN FILMS

Inventor: Ajit P. Paranjpe, et al.

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Docket: 021208.0238

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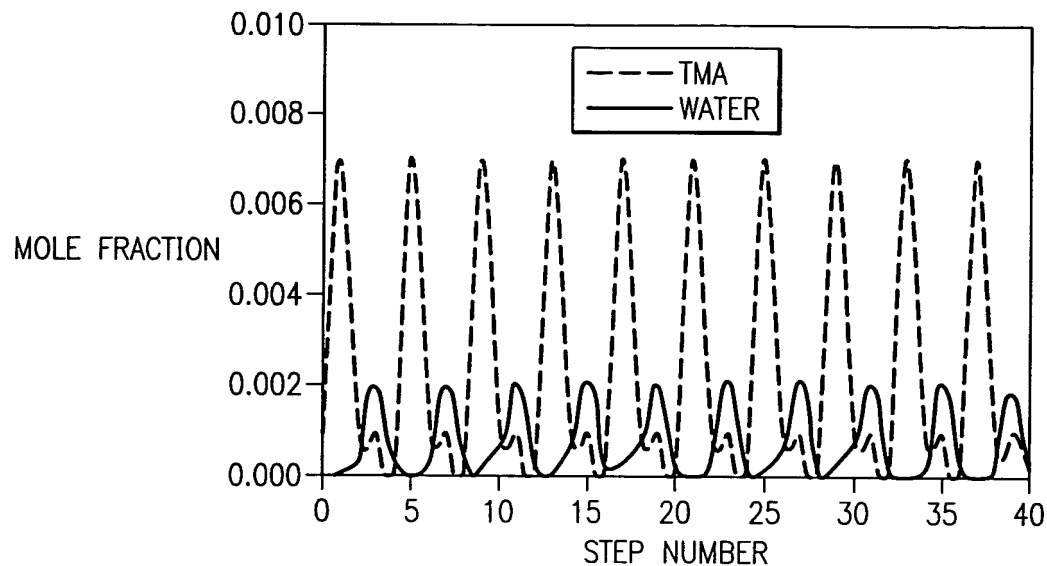


FIG. 4

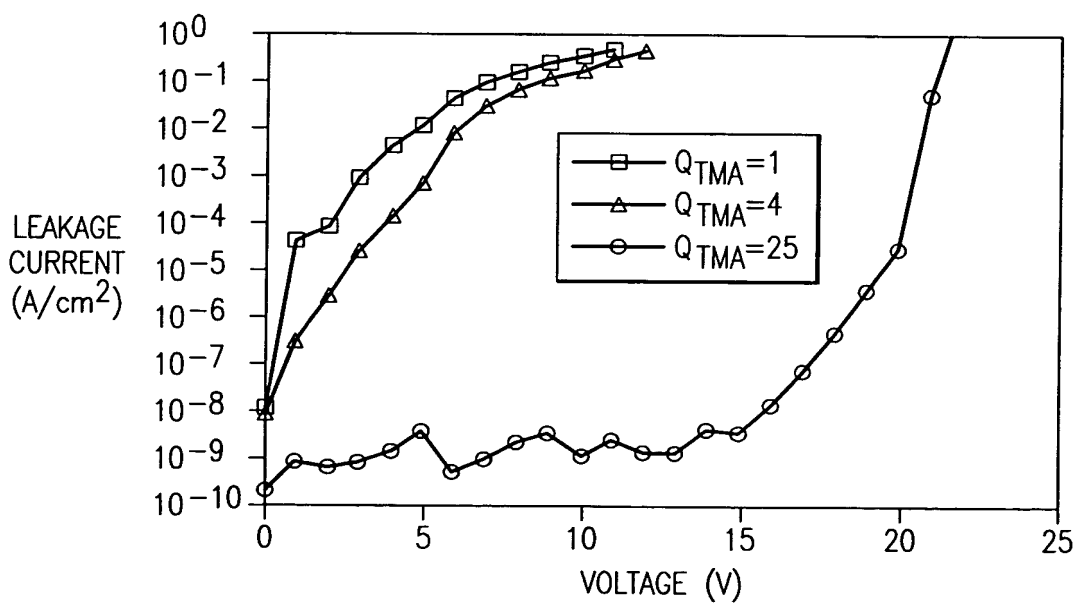


FIG. 5

REVISED	O.G. F.
BY	CLASS SU20
DRAFTSMAN	

ATOMIC LAYER DEPOSITION FOR FABRICATING THIN FILMS

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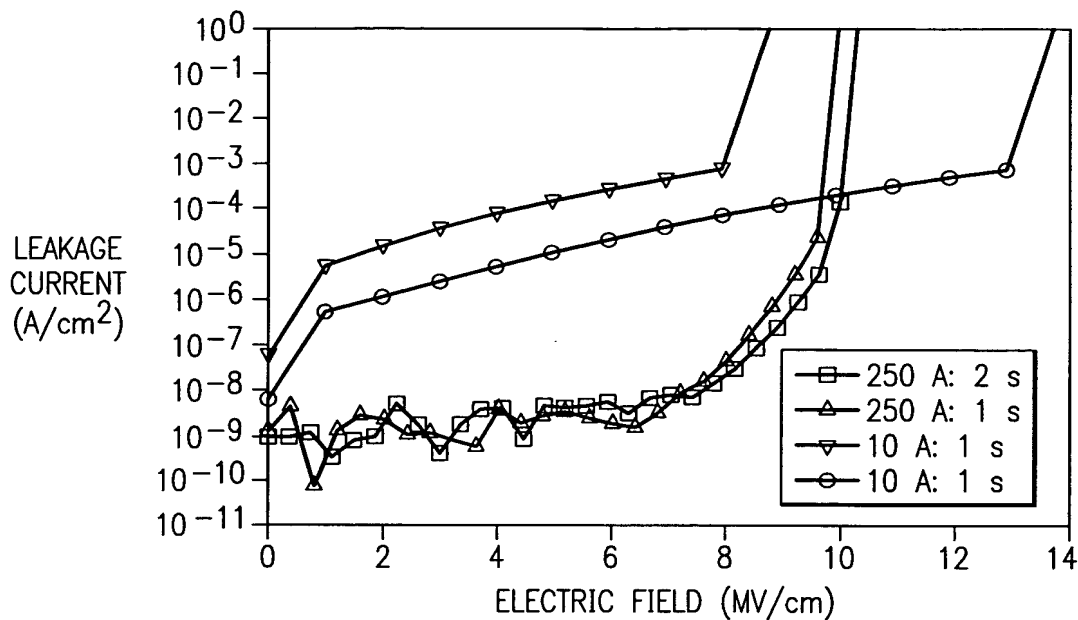


FIG. 6

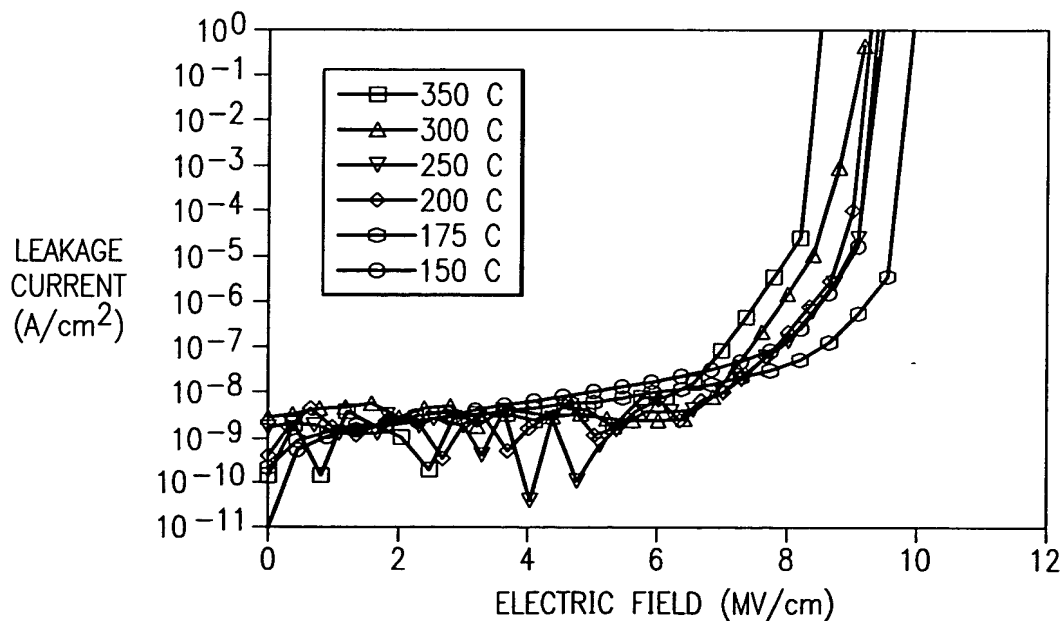


FIG. 7

APPROVED	O.G. FIG.	
BY	CLASS	SUBS.
CRAFTSMAN		

TOMIC LAYER DEPOSITION FOR ABRICATING THIN FILMS

inventor: Ajit P. Paranjpe, et al.
xpress: EL740056656US Docket: 021208.0238

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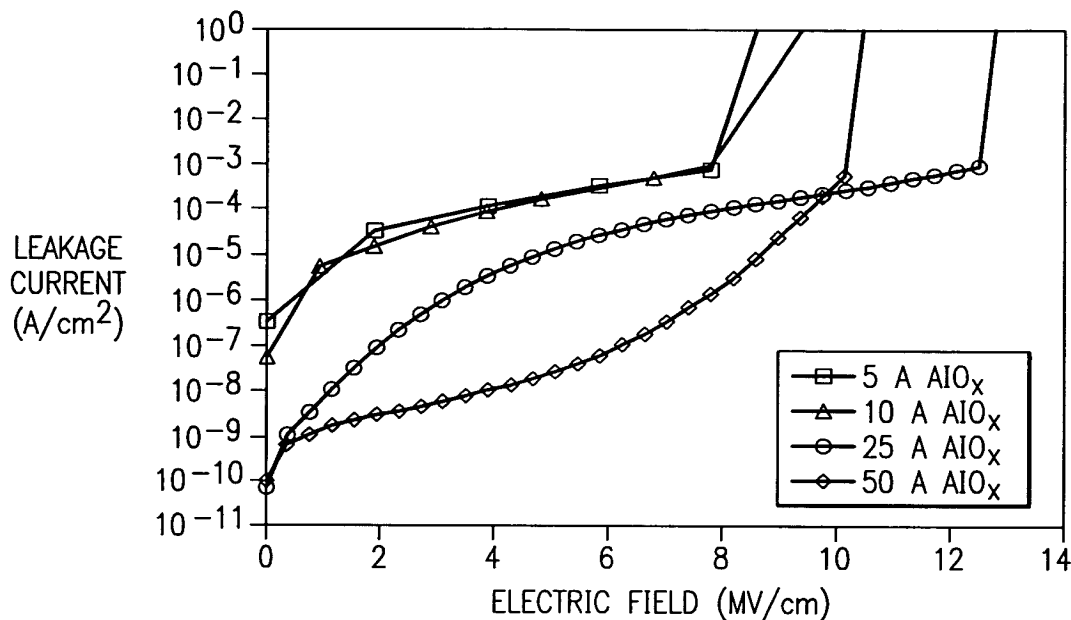


FIG. 8A

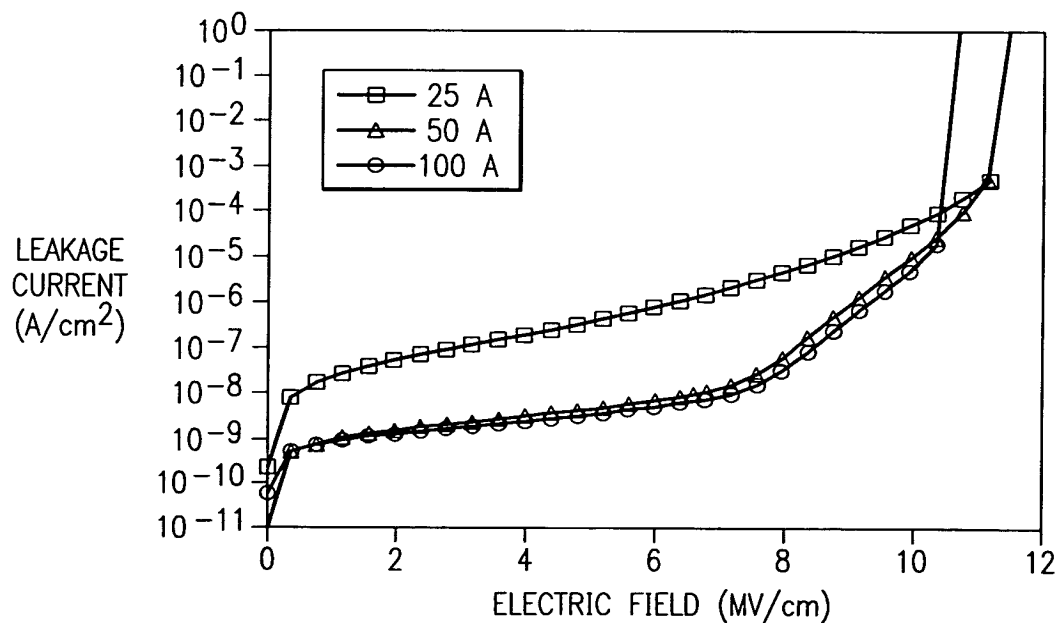


FIG. 8B

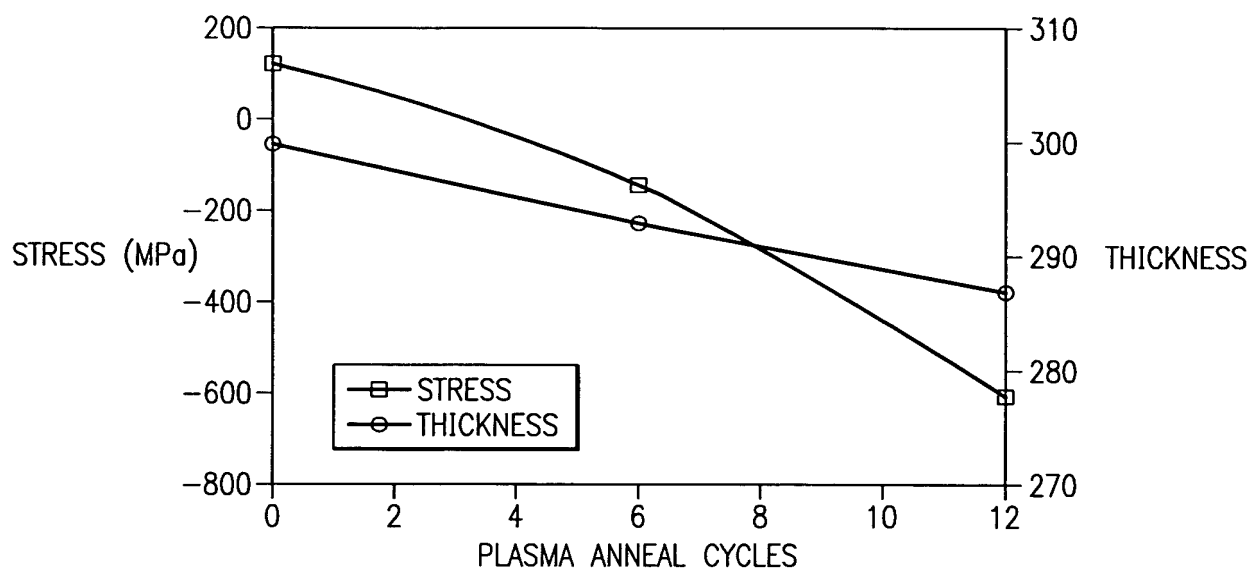


FIG. 9

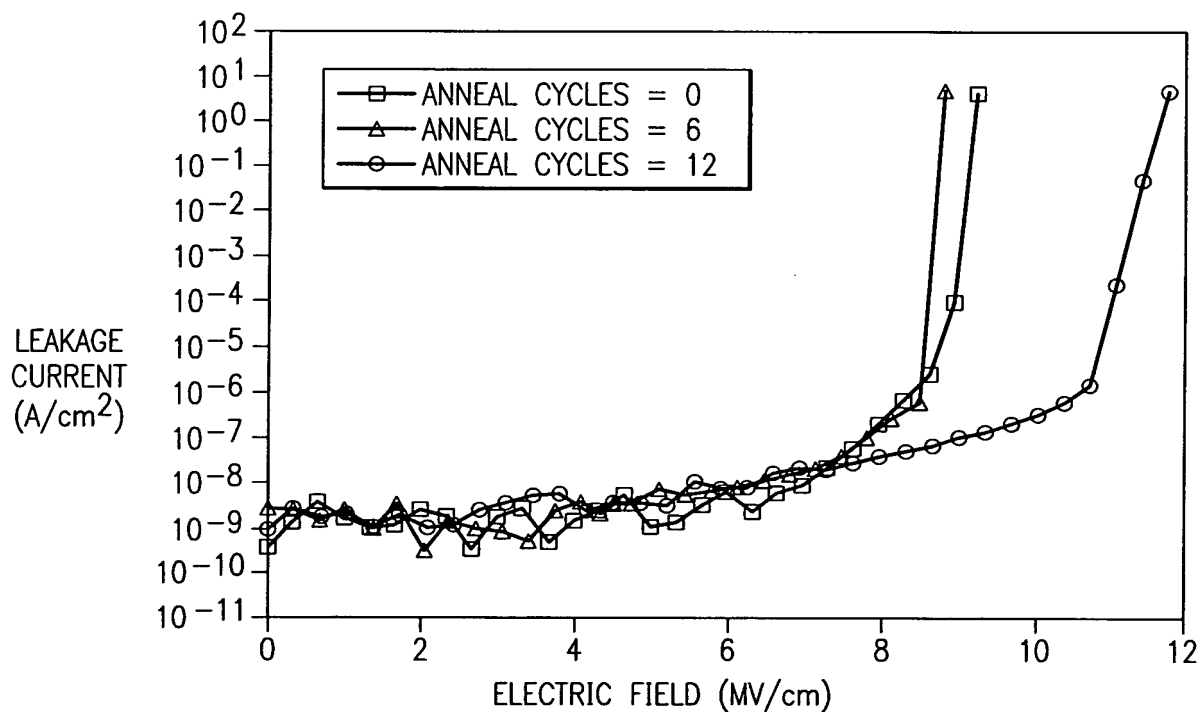


FIG. 10

APPROVED	O.G. FIG.	
BY	CLASS	SUBCLASS
DRAFTSMAN		

TOMIC LAYER DEPOSITION FOR ABRICATING THIN FILMS

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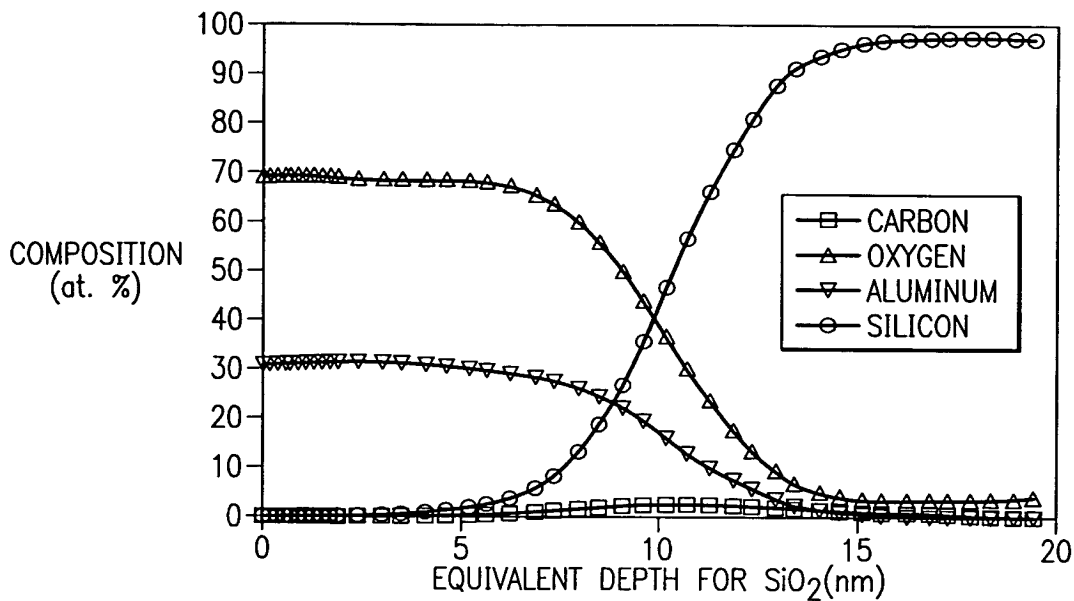


FIG. 11A

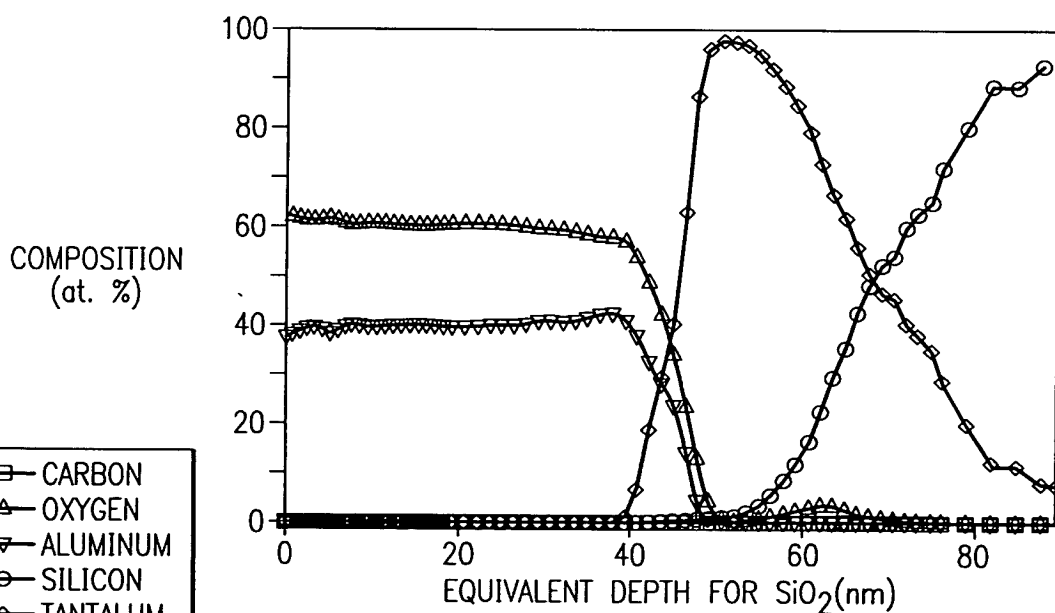


FIG. 11B